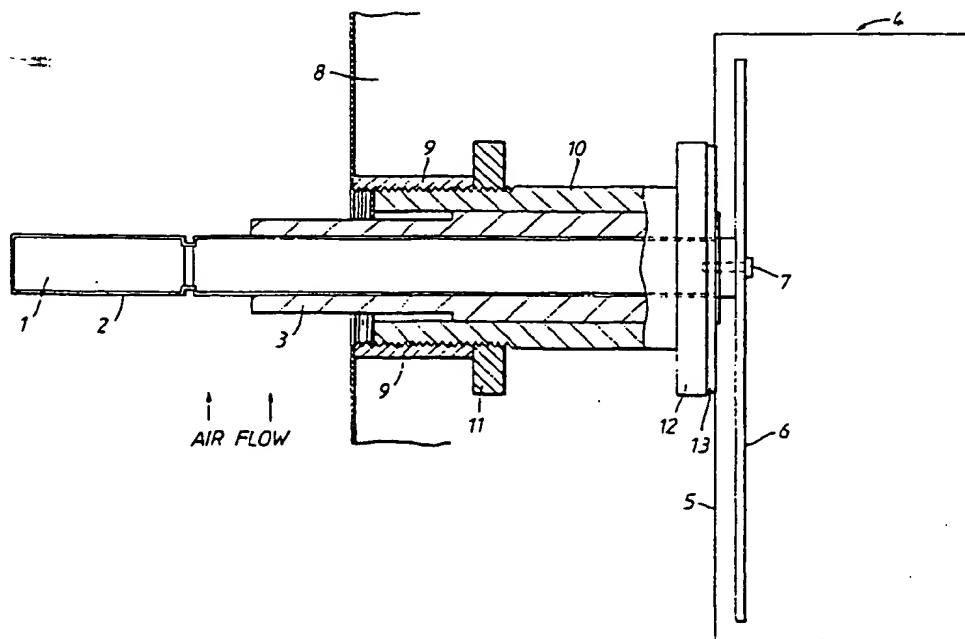


## INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification <sup>5</sup> : G01N 15/06, 27/60, G01P 5/08		A1	(11) International Publication Number: WO 94/23281 (EP 0693 178 B1)															
			(43) International Publication Date: 13 October 1994 (13.10.94)															
(21) International Application Number: PCT/GB94/00711		(81) Designated States: AT, AU, BB, BG, BR, BY, CA, CH, CN, CZ, DE, DK, ES, FI, GB, GE, HU, JP, KG, KP, KR, KZ, LK, LU, LV, MD, MG, MN, MW, NL, NO, NZ, PL, PT, RO, RU, SD, SE, SI, SK, TJ, TT, UA, US, UZ, VN, European patent (AT, BE, CH, DE, DK, ES, FR, GB, GR, IE, IT, LU, MC, NL, PT, SE), OAPI patent (BF, BJ, CF, CG, CI, CM, GA, GN, ML, MR, NE, SN, TD, TG).																
(22) International Filing Date: 31 March 1994 (31.03.94)																		
(30) Priority Data: 9307123.1      6 April 1993 (06.04.93)      GB																		
(71) Applicant (for all designated States except US): POLLUTION CONTROL AND MEASUREMENT (EUROPE) LTD. [GB/GB]; Stonehill, Stukeley Meadows Industrial Estate, Huntingdon, Cambridgeshire PE18 6EL (GB).		Published With international search report.																
(72) Inventors; and (75) Inventors/Applicants (for US only): RIGBY, Michael [GB/GB]; 61 Upwood Road, Bury, Cambridgeshire PE17 1PA (GB). THOMAS, Victor, Frederick [GB/GB]; 1 Prior's Road, Hemingford Grey, Cambridgeshire PE18 9BT (GB).		<table border="1"> <tr> <td>Vorlage</td> <td>Ablage</td> <td>01014</td> </tr> <tr> <td colspan="3">Haupttermin</td> </tr> <tr> <td colspan="3">Eing.: 15. SEP. 1999</td> </tr> <tr> <td colspan="3">PA. Dr. Peter Riebling</td> </tr> <tr> <td>Bearb.:</td> <td colspan="2">Vorgelegt.</td> </tr> </table>		Vorlage	Ablage	01014	Haupttermin			Eing.: 15. SEP. 1999			PA. Dr. Peter Riebling			Bearb.:	Vorgelegt.	
Vorlage	Ablage			01014														
Haupttermin																		
Eing.: 15. SEP. 1999																		
PA. Dr. Peter Riebling																		
Bearb.:	Vorgelegt.																	
(74) Agents: BARDO, Julian, Eason et al.; Abel & Imray, Northumberland House, 303-306 High Holborn, London WC1V 7LH (GB).																		

(54) Title: METHOD AND APPARATUS FOR DETECTING PARTICLES IN A FLOW



## (57) Abstract

An apparatus for detecting particles in a flow comprises a probe (1) positioned so that it projects into the flow and is charged triboelectrically by the particles in the flow. An electric circuit is coupled to the probe (1) and includes evaluating means for monitoring a signal from the probe (1) and for providing an output in dependence on the signal generated by the triboelectric charging of the probe (1). The part of the probe (1) that projects into the particle flow comprises an electrically conducting core covered with an insulating layer (2) which insulates the core from the particle flow.

**FOR THE PURPOSES OF INFORMATION ONLY**

Codes used to identify States party to the PCT on the front pages of pamphlets publishing international applications under the PCT.

AT	Austria	GB	United Kingdom	MR	Mauritania
AU	Australia	GE	Georgia	MW	Malawi
BB	Barbados	GN	Guinea	NE	Niger
BE	Belgium	GR	Greece	NL	Netherlands
BF	Burkina Faso	HU	Hungary	NO	Norway
BG	Bulgaria	IE	Ireland	NZ	New Zealand
BJ	Benin	IT	Italy	PL	Poland
BR	Brazil	JP	Japan	PT	Portugal
BY	Belarus	KE	Kenya	RO	Romania
CA	Canada	KG	Kyrgyzstan	RU	Russian Federation
CF	Central African Republic	KP	Democratic People's Republic of Korea	SD	Sudan
CG	Congo	KR	Republic of Korea	SE	Sweden
CH	Switzerland	KZ	Kazakhstan	SI	Slovenia
CI	Côte d'Ivoire	LI	Liechtenstein	SK	Slovakia
CM	Cameroon	LK	Sri Lanka	SN	Senegal
CN	China	LU	Luxembourg	TD	Chad
CS	Czechoslovakia	LV	Latvia	TG	Togo
CZ	Czech Republic	MC	Monaco	TJ	Tajikistan
DE	Germany	MD	Republic of Moldova	TT	Trinidad and Tobago
DK	Denmark	MG	Madagascar	UA	Ukraine
ES	Spain	ML	Mali	US	United States of America
FI	Finland	MN	Mongolia	UZ	Uzbekistan
FR	France			VN	Viet Nam
GA	Gabon				

## METHOD AND APPARATUS FOR DETECTING PARTICLES IN A FLOW.

This invention relates to a method and apparatus for monitoring particles.

The invention particularly relates to an arrangement in which a probe projecting into a flow of particles is charged triboelectrically by flowing particles colliding with the probe.

WO 86/02454 describes an apparatus for monitoring particles in a gas flow through a conduit. A metal probe is installed in a flow of gas containing solid particles and the probe is coupled to an electric circuit containing processing means. The probe is charged triboelectrically by the particles colliding with the probe and the resulting current in the circuit is processed to give an output that gives a measure of the flow rate of the particles.

US 5 054 325 shows an apparatus for measurement of fluid flows with suspended solid particles, using a triboelectric probe embedded in the wall of the conduit through which the fluid flows, where the fluid flow is a liquid or gas.

Our co-pending application no. GB 92.09407 (published under the serial number GB 2 266 772) the content of which is incorporated herein by reference also describes an arrangement for monitoring particles in a gas flow. An electrically conducting rod is mounted in a

stack and is coupled to a processing circuit. The rod is charged triboelectrically by the particles in the gas flow and the signal generated in the circuit is evaluated to give an output giving an indication of the particle  
5 flow. The rod is insulated at the point where it is mounted in the stack wall to prevent currents being transmitted to and from the stack wall, but of course the insulating material does not extend over the whole outer surface of the conducting rod.

10 In the arrangements described above, a probe extends into the fluid flow and obstructs the flow of the particles. It has been found that if the probe is mounted in a duct wall or the like, particles can build up in the region between the electrically conducting  
15 probe and the duct wall and, especially in damp conditions, form an electrically conducting path between the probe and the duct wall.

As a result, the charge transferred to the probe by the particles in the flow can pass through the built-up  
20 material and through the duct wall to earth. Thus the output of the processing circuit may not give an accurate measure of the particle flow.

In addition, small currents that exist in the duct wall can be transmitted via the probe into the processing  
25 circuit connected to the probe. The magnitude of the currents generated by the triboelectrical charging of the probe in the circuit may be of the same order as those

that exist in the duct wall and so the output of the circuit may not give an accurate measure of the particle flow.

A further problem is that the metal probe and the duct wall may begin to operate as a battery, introducing more undesirable currents into the processing circuit, again giving an inaccurate measure of the particle flow.

It is an object of the invention to provide an improved method and apparatus for detecting particles in a flow that avoids or mitigates the above problems and gives a reliable indication of the particle flow.

Accordingly, the present invention provides a method of detecting particles in a flow in which a probe is positioned so that it projects into the flow of particles and is charged triboelectrically by the particles in the flow and a signal from the probe is evaluated to provide an indication of the particle flow, characterised in that the part of the probe that projects into the particle flow comprises an electrically conducting core covered with an insulating layer which insulates the core from the particle flow.

Advantageously the A.C. component of the signal is evaluated to provide an indication of the particle flow. Although the A.C. component of the signal generated in the circuit by triboelectrical charging of the probe is small when compared with the D.C. component, it has been found that the A.C. component of the signal gives a more

accurate reflection of the particle flow than the absolute value of the signal. It is believed that factors such as humidity, electrical charges already on the particles and a build-up of particles on the probe  
5 all affect the absolute value of the current without affecting the alternating component of the current as much. We have found furthermore that the combination of providing an insulated probe and evaluating the A.C. component is especially advantageous because the use of  
10 A.C. is especially suited to the case where the probe is insulated.

Preferably the alternating component of the signal from the probe is filtered to limit the frequency to below about 5 Hz. The frequency may be limited to below  
15 2 Hz, preferably about 1.5 Hz. By eliminating higher frequencies the risk of spurious signals derived from mechanical vibration of the probe is substantially reduced since the resonant frequency of such vibration is likely to be substantially higher than 5 Hz.

20 Preferably the alternating component of the signal from the probe is filtered to limit the frequency of the signal to above about 0.1 Hz, preferably about 0.15 Hz. By eliminating lower frequencies the risk of spurious signals derived from transient temperature-generated  
25 voltages is substantially reduced.

Preferably the alternating component of the signal from the probe is amplified in a plurality of stages. In

that case low frequencies, which may be those below 0.15 Hz, are preferably attenuated at the first stage of amplification.

The particles may be suspended in a fluid flow.

- 5 The fluid flow may be either a gas or a non-electrically conducting liquid and the particles may be either liquid or solid particles.

The flow may be a gas flow through a stack with suspended particles that are emitted through the stack.

- 10 The flow may be through a duct having a probe mounted in the duct.

- The present invention also provides an apparatus for detecting particles in a flow comprising a probe to be positioned so that it projects into the flow to be
- 15 charged triboelectrically by the particles in the flow, and an electric circuit coupled to the probe having evaluating means for monitoring a signal from the probe and for providing an output in dependence on the signal generated by the triboelectric charging of the probe,
- 20 characterised in that the part of the probe to project into the particle flow comprises an electrically conducting core covered with an insulating layer which insulates the core from the particle flow.

- Advantageously, the electric circuit comprises
- 25 evaluating means for monitoring the A.C. component of the signal from the probe. The probe may be in the form of a rod. The rod probe may be of circular cross-section.

It is, of course, entirely unconventional to use an insulated probe to monitor triboelectrical charging but we have found the use of such a probe to be surprisingly effective in the present invention, especially in terms of overcoming the problems referred to above.

In the prior art particle monitoring arrangements, a conducting rod probe is mounted in a duct wall with the electrically conducting surface of the probe exposed to the gas flow and the probe is coupled to a processing circuit. It is believed that a current is generated by the rod probe in the following ways:

(1) When a particle collides with the probe there is a "rubbing" of the particle against the probe leading to direct triboelectric charging.

(2) Particles in the flow may become charged by collisions with other particles. When a charged particle collides with the conducting probe, the particle gives up some or all of its charge to the probe. The particle may be charged positively or negatively and the current generated will vary accordingly.

(3) A charged particle in the flow passing the probe may, even though it does not touch the probe, induce a charge in the probe which causes a current to flow.

In the case of the present invention it is believed that currents are usually generated as a result of all three of the effects described above although precisely



what happens is not fully understood. It is believed that the probe and evaluating means of the present invention may be likened in electrical terms to the same evaluating means coupled to a non-insulated probe  
5 connected in series with a capacitor.

Advantageously, the size and composition of the particles in the flow does not vary and the flow is monitored in order to detect variations in the mass flow rate. Given that the size of the particles and their  
10 composition does not vary, the measurement of mass flow rate can alternatively be regarded as a measurement of the flow rate in terms of the number of particles per unit time.

Usually it will be desired to provide a quantitative  
15 indication of the mass flow rate but for some applications it may be adequate simply to provide an indication of whether or not the mass flow rate measured is above or below some threshold level. An alarm may be sounded if the mass flow rate is above the threshold  
20 level.

The invention can be used to monitor a flow of solid particles alone or to monitor solid or liquid particles suspended in a gas or liquid flow. The invention can be used to provide a continuous measurement of the mass flow  
25 rate of the suspended particles. The invention has many applications in industrial plants using particle collection and dry solids handling processes. It may be

used, for example, to monitor the performance of a filter. A particularly advantageous and important use for the invention is the measurement of the emission of particles classified as pollutants through a stack to the atmosphere. The invention can also be used in a manufacturing process where it is necessary to monitor and control the addition or recovery of particulate matter. For example, the invention may be used in a system where particles are suspended in a gas stream, as in a pneumatic conveying system.

An apparatus and method for monitoring flow of particles in accordance with the invention will now be described by way of example only with reference to the accompanying drawings, in which:

Fig 1 is a sectional view of the sensing head of the dust flow monitoring apparatus mounted in the wall of a stack through which dust particles in a flow of air are emitted;

Fig 2 is a sectional view of the insulated probe assembly of the sensing head;

Fig 3 is a block diagram representation of the electrical system of the dust flow monitoring system;

Fig 4 is a graph showing the d.c. voltage outputs from the monitoring system monitoring an air flow to which polyvinylchloride (PVC) dust particles have been added at two different constant rates;

With reference to Fig 1 of the accompanying

drawings, the sensing head of the dust flow monitoring apparatus generally comprises a metal probe 1 with a layer of insulating material 2 on the outer surface, an insulated support member 3, made of PTFE, and an electronic sensor unit 4 comprising a waterproof box 5 containing an electronic circuit board 6.

With reference to Fig 2, the probe assembly is a metal rod 1 of circular cross-section with a diameter of 16mm and 150mm long made of stainless steel and coated on the outer surface, using known techniques, with a nylon powder coating 2. The stainless steel rod is coated with the insulating material over the entire surface except the end of the rod that is to be connected to the circuit board. The thickness of the insulating layer is 5µm.

Fig. 1 shows the probe and a sensor unit 4 making up the sensing head fitted in the stack wall 8.

The electronic sensor unit 4 comprises an aluminium cover 5 containing a circuit board 6 carrying signal evaluating means and is connected to the metal probe by means of a connection screw 7. The connection screw 7 passes through the circuit board 6 and connects it to the metal probe 1.

The sensing head is mounted in the stack wall 8 in the following way. A position for mounting the sensing head 11 in the stack is chosen where the gas flow is reasonably linear, for example, as shown, in a straight section of the stack. An internally screw threaded

sleeve 9 is then welded into the stack at the chosen position. An outer metal sleeve 10 having an external screw thread matching the internal thread on the coupling is fitted around the insulating support member 3. The  
5 sensing head is then inserted into the stack wall and screwed into place so that the probe extends into the gas flow. A lock nut 11 secures the sensing head in the stack wall. A second lock nut 12 acts on a sealing gasket 13 that is placed around the end of the probe  
10 between the metal sleeve 10 and the sensing unit 4.

As shown in Fig. 1 the probe projects into the shaft of the stack in a direction transverse to the direction of flow of air through the stack. Particles in the air flow collide with the probe and triboelectric charging  
15 takes place. A signal is thus produced in the circuit coupled to the probe.

Fig. 3 shows a block diagram illustrating the electronic circuitry of the dust monitoring apparatus. Our co-pending application no. GB 90.09407 describes in  
20 full detail the circuitry used to evaluate a current generated by a metal probe in an apparatus for detecting particles in a gas flow. The same circuitry is used in the dust monitoring apparatus described here. However, as described above, the signal generated in the circuit  
25 by the insulated probe is different from the signal generated in the circuit when it is coupled to a non-insulated metal probe. The electronic circuit board in

the sensor shown in Fig. 1 contains the input amplifier 22, the first coupling network 23, the second stage amplifier 24 and the gain-change logic circuit 25. The rest of the electrical system is "control room" equipment and is located at a position remote from the sensing head.

The signal is processed in the same way as is described in our co-pending application GB 2 266 772. Briefly, referring to Fig. 3, the current supplied by the probe is amplified and subjected to bandwidth shaping. The signal is also passed through coupling networks 23,102 containing capacitors that block the d.c. and very low frequency signals in the circuit. Finally, the signal is passed to an averaging filter and output amplifier 104 that provides a long-term average of the signals, reducing the random signal variations which particle flow provides. The output signal from the output amplifier is passed to a voltage-to-current converter 105 for driving a pen-recorder or the like.

Also, a signal from the averaging filter and output amplifier 104 is applied to the alarm logic and controller 106 which is set to trigger when a set level is exceeded. There is also an arrangement for setting the alarm logic and controller to trigger when the applied signal falls below a set threshold.

Because the outer layer of the probe is electrically insulated, even if there is a build-up of particles in

the region between the probe and the stack wall, there is no electrically conducting path between the stack wall and the processing circuit.

In that way the reading given by the dust monitoring apparatus is a more accurate measure of the particle flow.

Fig. 4 shows the results, in the form of voltage in volts plotted against time in minutes, of a test carried out to measure the result of monitoring particles using the monitoring apparatus described above at given densities in an air flow through a duct. In the test, PVC particles of substantially constant size of 200 microns were added to air flowing at a rate of 18.5 m/s through a duct of circular cross-section. The particles were first added at a substantially constant rate of the order of 7.7 mg/m<sup>3</sup> and the output from the evaluating means was measured. Similarly, PVC particles were later added at a substantially constant rate of approximately 3.1mg/m<sup>3</sup> and the output was again measured. Fig. 4 shows that the reading obtained by the evaluating means in each case is substantially constant and approximately proportional to the density of the particles.

The invention is not limited to use in a stack as described above. As will be clear to a person skilled in the art, the invention can be used to monitor any flow of particles, whether flowing under the action of gravity, or suspended in a gas or non-electrically conducting

liquid. Other types of insulating material would be suitable for use on the probe. For example, the insulating layer could be nylon, polytetrafluoroethene (PTFE), ceramic or any plastic, whether thermoplastic or thermosetting, and it could be in the form of a coating or a sleeve. Although the circuit described above coupled to the probe evaluates the A.C. component of the signal generated by the probe, the insulated probe is also suitable for use with a circuit where the D.C. component, or both the A.C. and the D.C. component, of a signal generated by the probe is evaluated to give an output reading that is a measure of the particle flow.

## CLAIMS

1. A method of detecting particles in a flow in which a probe is positioned so that it projects into the flow of particles and is charged triboelectrically by the  
5 particles in the flow and a signal from the probe is evaluated to provide an indication of the particle flow, characterised in that the part of the probe that projects into the particle flow comprises an electrically conducting core covered with an insulating layer which  
10 insulates the core from the particle flow.
2. A method of detecting particles in a flow as claimed in claim 1 in which the A.C. component of a signal from the probe is evaluated to provide an indication of the particle flow.
- 15 3. Method as claimed in claim 1 or 2 in which the particles are suspended in a fluid flow and the probe is charged triboelectrically by the particles in the fluid flow.
4. A method as claimed in claim 3 in which the fluid is  
20 a non-electrically conducting liquid and the particles are liquid or solid particles suspended in the liquid.
5. A method as claimed in claim 3 in which the fluid is a gas and the particles are liquid or solid particles suspended in the gas.
- 25 6. A method as claimed in any of claims 1 to 5 which the fluid flow is along a duct and the probe is mounted in the duct.



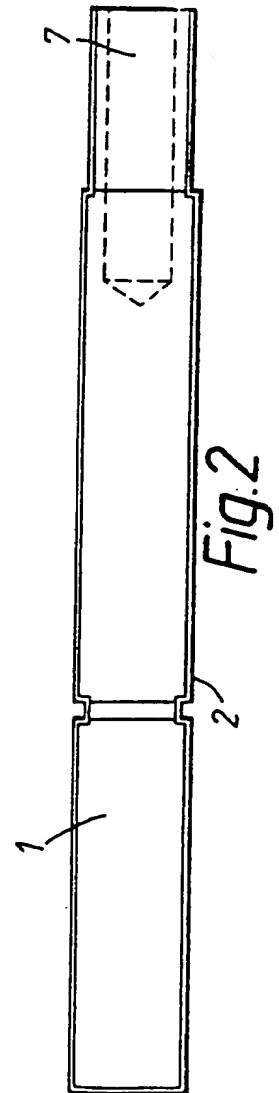
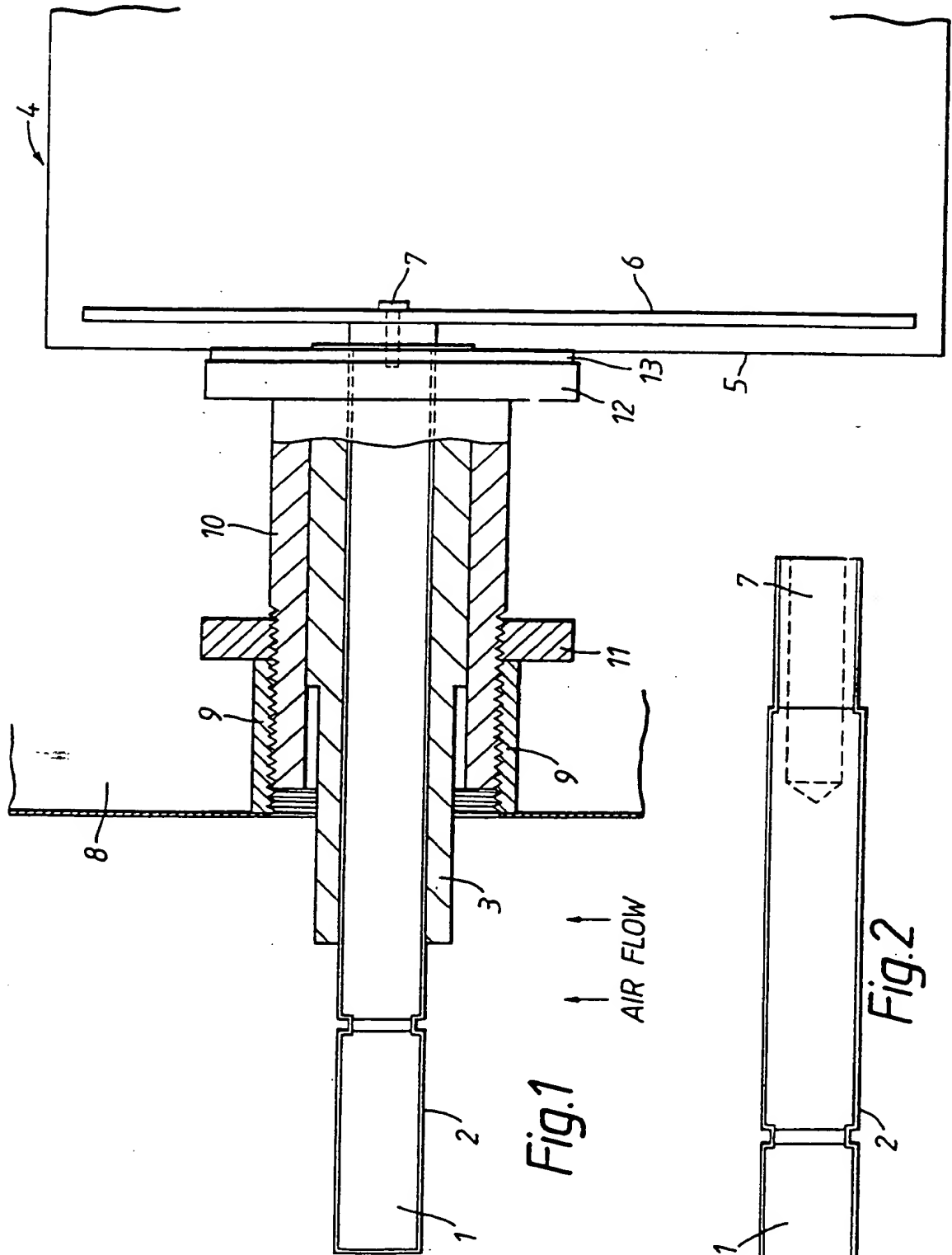
7. A method as claimed in claim 5 in which the gas is flowing along a stack or duct and the particles are emitted through the stack or duct.

8. Apparatus for detecting particles in a flow  
5 comprising a probe to be positioned so that it projects into the flow to be charged triboelectrically by the particles in the flow, and an electric circuit coupled to the probe having evaluating means for monitoring a signal from the probe and for providing an output in dependence  
10 on the signal generated by the triboelectric charging of the probe, characterised in that the part of the probe to project into the particle flow comprises an electrically conducting core covered with an insulating layer which insulates the core from the particle flow.
- 15 9. Apparatus as claimed in claim 8 characterised in that the electric circuit has evaluating means for monitoring an A.C. component of the a signal from the probe for providing an output in dependence on the signal generated by the triboelectric charging of the probe.
- 20 10. Apparatus as claimed in claim 8 or 9 characterised in that the probe is in the form of a rod.
11. Apparatus as claimed in claim 10 characterised in that the rod is of circular cross-section.
12. Apparatus for detecting particles in a flow , the  
25 apparatus being substantially as herein described with reference to and as illustrated by the accompanying drawings.

13. A method as described in claim 1 using an apparatus as claimed in any of claims 8 to 12.

14. A method for detecting particles in a flow, the method being substantially as herein described with  
5 reference to and as illustrated by the accompanying drawings.

1/3



2/3

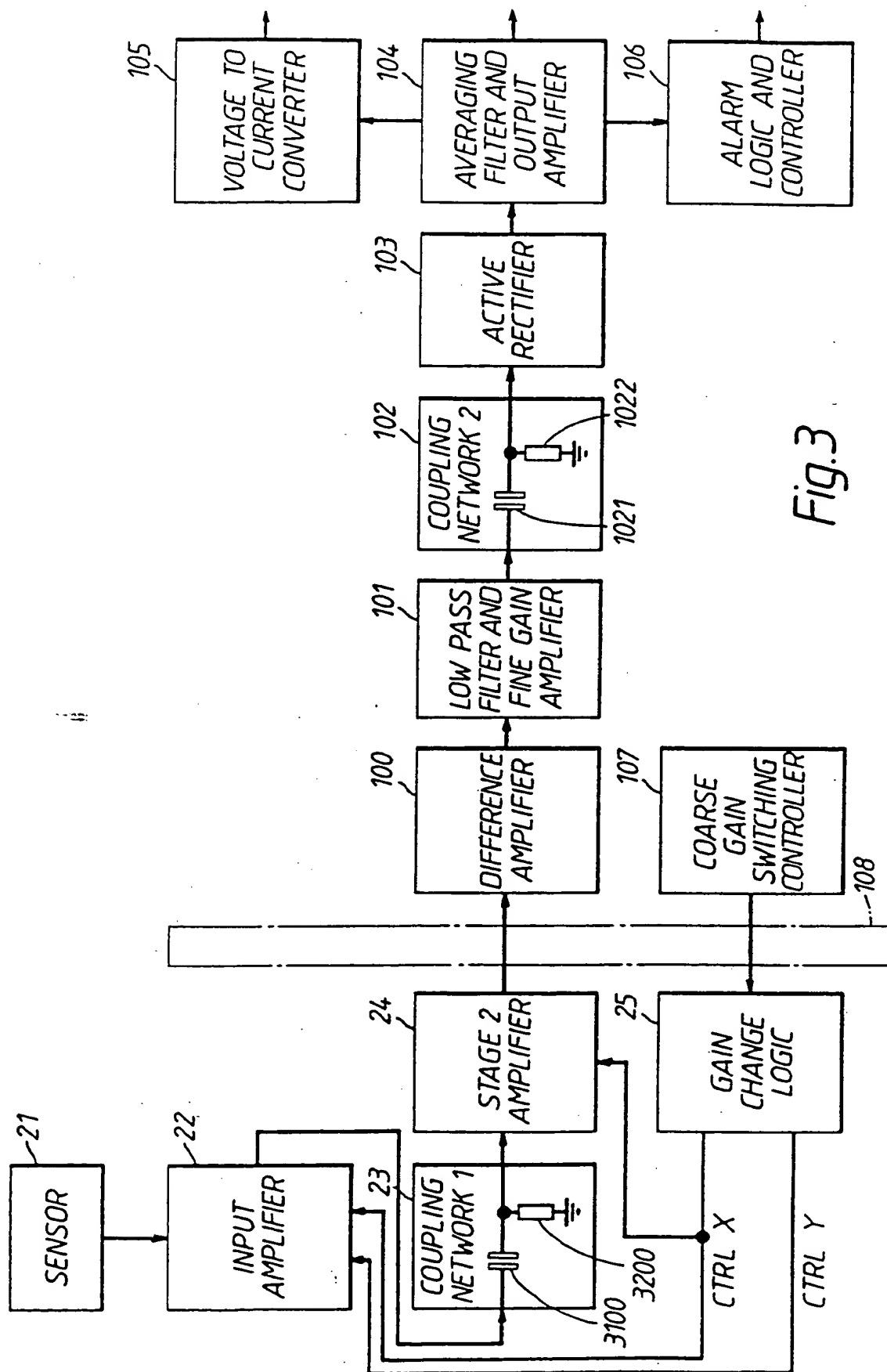


Fig.3

3/3

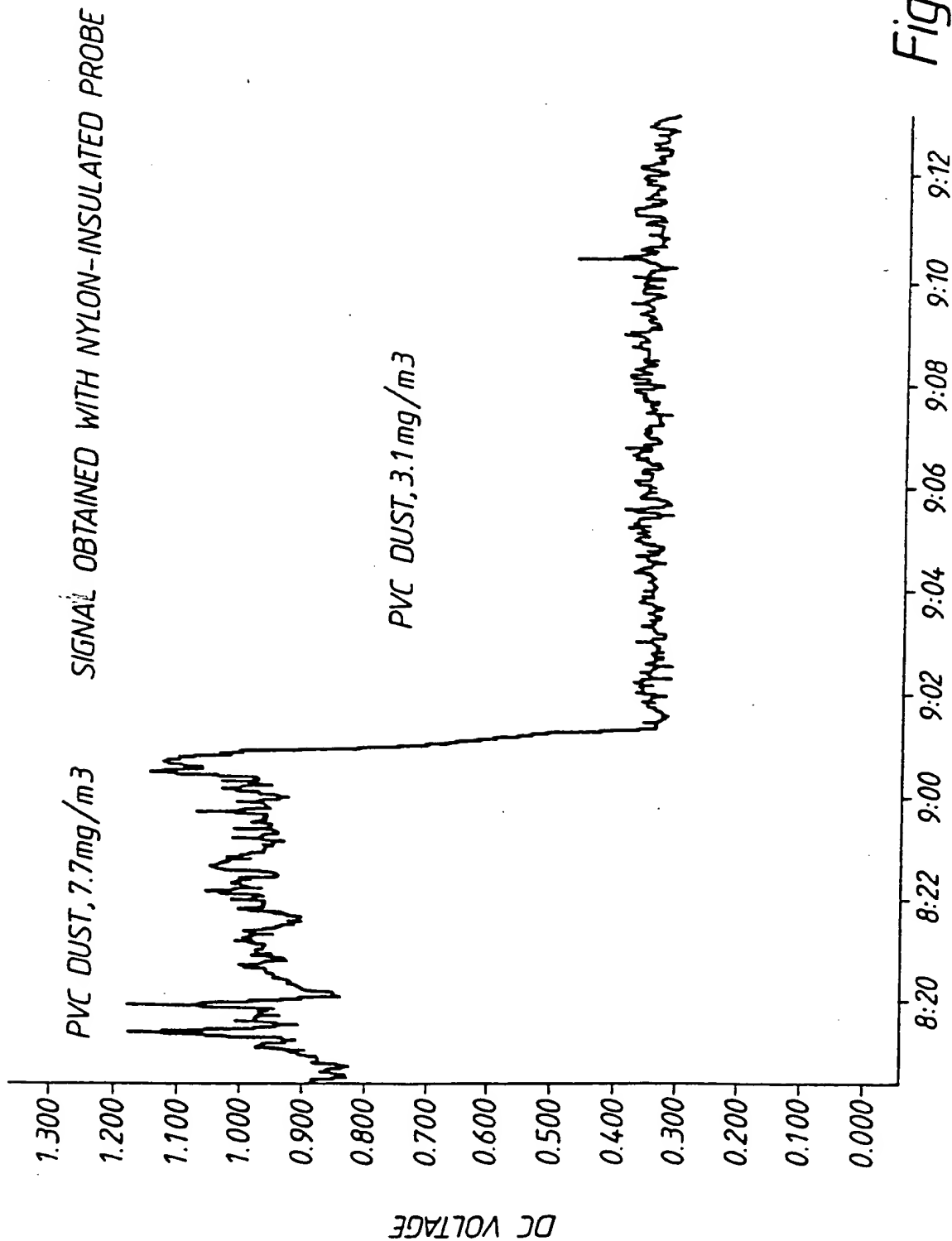


Fig.4

## INTERNATIONAL SEARCH REPORT

Patent Application No.

PCT/GB 94/00711

## A. CLASSIFICATION OF SUBJECT MATTER

IPC 5 G01N15/06 G01N27/60 G01P5/08

According to International Patent Classification (IPC) or to both national classification and IPC

## B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 5 G01N G01F G01P

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

## C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category *	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	EP,A,0 110 802 (AMBAC INDUSTRIES) 13 June 1984 see page 10, line 22 - line 25 see page 13, line 16 - line 24; claims 1-21 ---	1,8
X	GB,A,2 166 874 (KIMBERLY-CLARK CORPORATION) 14 May 1986 see page 1, line 109 - line 130; claims 1-10 ---	1,8
A	US,A,4 607 228 (R.B.REIF) 19 August 1986 see claims 1,20 ---	1,8, 12-14
A	WO,A,86 02453 (AUBURN INTERNATIONAL) 24 April 1986 see claims 1-7 ---	8
	---	

-/--

☒ Further documents are listed in the continuation of box C.☒ Patent family members are listed in annex.

## \* Special categories of cited documents:

- \*A\* document defining the general state of the art which is not considered to be of particular relevance
- \*E\* earlier document but published on or after the international filing date
- \*I\* document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
- \*O\* document referring to an oral disclosure, use, exhibition or other means
- \*P\* document published prior to the international filing date but later than the priority date claimed

\*T\* later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention

\*X\* document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone

\*Y\* document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art

\*&\* document member of the same patent family

Date of the actual completion of the international search

6 July 1994

Date of mailing of the international search report

13.07.94

Name and mailing address of the ISA

European Patent Office, P.B. 5818 Patentaan 2  
NL - 2280 HV Rijswijk  
Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,  
Fax (+31-70) 340-3016

Authorized officer

Van den Bulcke, E

## INTERNATIONAL SEARCH REPORT

International Application No

PCT/GB 94/00711

## C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
A	DE,B,11 95 960 (J.C.ECKARDT A .G.) 1 July 1965 ----	
A	FR,A,2 215 608 (EROTERV) 23 August 1974 ----	
A	GB,A,2 121 542 (HASLER FRERES SA) 21 December 1983 see page 3, line 120 - line 124; claims 1-13 ----	1,8
A	US,A,5 054 325 (R.L.DECHENE) 8 October 1991 ----	
A	US,A,4 512 200 (W.L.GHERING) 23 April 1985 ----	
A	PATENT ABSTRACTS OF JAPAN vol. 011, no. 173 (P-582) 4 June 1987 & JP,A,62 003 621 (MITA IND CO LTD) 9 January 1987 see abstract ----	
A	PATENT ABSTRACTS OF JAPAN vol. 011, no. 173 (P-582) 4 June 1987 & JP,A,62 003 622 (MITA IND CO LTD) see abstract -----	

# INTERNATIONAL SEARCH REPORT

Information on patent family members

Patent Application No

PCT/GB 94/00711

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
EP-A-0110802	13-06-84	US-A- 4456883 AU-A- 1985383 CA-A- 1194116 JP-C- 1713179 JP-B- 3076706 JP-A- 59094061	26-06-84 12-04-84 24-09-85 27-11-92 06-12-91 30-05-84
GB-A-2166874	14-05-86	US-A- 4594901 AU-A- 4949285 DE-A- 3539734 FR-A- 2575823 JP-A- 61118617	17-06-86 15-05-86 03-07-86 11-07-86 05-06-86
US-A-4607228	19-08-86	NONE	
WO-A-8602453	24-04-86	US-A- 4631482 AU-B- 573046 AU-A- 4952185 CA-A- 1277389 DE-A- 3585879 EP-A, B 0199760 JP-T- 62500400	23-12-86 26-05-88 02-05-86 04-12-90 21-05-92 05-11-86 19-02-87
DE-B-1195960		NONE	
FR-A-2215608	23-08-74	DE-A- 2403605	05-09-74
GB-A-2121542	21-12-83	CH-A- 650590 DE-A- 3313464	31-07-85 15-12-83
US-A-5054325	08-10-91	NONE	
US-A-4512200	23-04-85	CA-A- 1211215 EP-A- 0144193 JP-B- 5016536 JP-A- 60200125	09-09-86 12-06-85 04-03-93 09-10-85